

## ABSTRACT OF THE DISCLOSURE

A silicon wafer wherein stacking fault (SF) nuclei are distributed throughout the entire in-plane direction, and the density of the stacking fault nuclei is set to a range of

5 between  $0.5 \times 10^8 \text{cm}^{-3}$  and  $1 \times 10^{11} \text{cm}^{-3}$ .